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**PATENT**  
**Docket No. P1572**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**APPLICANTS:** JENNIFER WANG  
HUI-MIN SHENG  
MIKE BARSKY

**SERIAL NO.** 10/782,723 **EXAMINER:** CHEN, KIN CHAN

**FILED:** FEBRUARY 18, 2005 **ART UNIT:** 1765

**TITLE:** DRY ETCHING PROCESS FOR COMPOUND  
SEMICONDUCTOR

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**RESPONSE AND AMENDMENT**

Sir:

Applicants submit this Request for Continued Examination and Amendment in response to the Office Action of June 13, 2006. Please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.